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S/N 10/825,033

**PATENT** 

Applicant:

**FUJIMORI** 

Examiner:

K. Lee

Serial No.:

10/825,033

Group Art Unit:

2812

Filed:

April 14, 2004

Docket No.:

12844.0015USD1

Title:

METHOD OF MANUFACTURING FERROELECTRIC SUBSTANCE

THIN FILM AND FERROELECTRIC MEMORY USING THE

FERROELECTRIC SUBSTANCE THIN FILM

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.

2007.

## **CHANGE OF ADDRESS**

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Dear Sir:

Please change the correspondence address for the above-referenced patent application to:

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If there are any questions regarding this matter, please call the undersigned at

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Respectfully submitted,

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(612) **4**53

Dated: February 13, 2007

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